

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				Docket Number (Optional)		Application Number	
				03850/010001		09/934,262	
				Applicant(s) Oliver KIENZLE et al.			
				Filing Date		Group Art Unit	
				August 21, 2001		2881	

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KN	A1	5,648,188	07/15/1997	Doran	430	22	06/07/1995
	A2	6,204,509	03/20/2001	Yahiro et al.	250	491.1	11/12/1998
		See PTO-892					

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	A1	11-142121	05/28/1999	Japan	G01B	11/16		<input checked="" type="checkbox"/>
		not received						

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
	A4	European Search Report dated December 29, 2003 (2 pages) not received
	A5	R. C. Farrow et al., "Marks for Alignment and Registration in Projection Electron Lithography"; Journal of Vacuum Science & Technology B; Vol. 11, No. 6, Nov/Dec 1993; pp. 2175-2178 not received

EXAMINER <div style="text-align: center;">K. MUYEN</div>	DATE CONSIDERED <div style="text-align: center;">10-20-04</div>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.